AMENDMENT TRANSMITTAL PETTER (SMALL)					Docket No.		
Applicant(s): Kevin P. Martin tal.					62002-1751		
Serial No. 09/855,972	09/855,972 May 15, 2001 A TRADEN Massai		niner C nzadeh, rvis	Confirmation No. 1603		Group Art Unit 1763	
Invention: Method and Apparatus for Low Energy Electron Enhanced Etching or Substrates in an AC or DC Plasma Environment							
Commissioner for Patents Mail Stop Non-Fee Amendment P.O. Box 1450 Alexandria VA 22313-1450 Transmitted herewith is the Fifth Response in the above-identified application.						IVED 0 20103	
Transmitted herewith is the Fifth Response in the above-identified application. The fee has been calculated and is transmitted as shown below							
CLAIMS AS AMENDED							
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	-	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	14 -	35 =	0	X	\$9.00	\$0.00	
INDEP. CLAIMS	2 -	4 =	0	X	\$43.00	\$0.00	
Multiple Dependent Claims (check if applicable)					\$145.00 \$		
EXTENSION FEE	1 ST MONTH	2 ND MONTH	3 RD MONTH 475.00	- 1	ONTH 🗌 40.00	\$	
Other Fees:						\$	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$0.00	
 No additional fee is required for the Fifth Response. □ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. A duplicate copy of this page is enclosed. □ A Credit Card Payment Form PTO-2038 is attached in the amount of \$ □ The Director is hereby authorized to charge any deficiencies of the above fees or credit any overpayment to Deposit Account No. 20-0778. A duplicate copy of this page is enclosed. 							
Scott A. Horstemeyer, Reg. No. 34,183							

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CERTIFICATE OF MAILING

I hereby certify that the below listed items are being deposited with the U.S. Postal Service as first class mail in an envelope addressed to:

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

on *October 7, 2003*

Signature -

RECEIVED

OCT 2 0 2003

TC 1700

In Re Application of:

Confirmation No.: 1603

Kevin P. Martin et al.

Group Art Unit: 1763

Serial No.: 09/855,972

Examiner: Hassanzadeh, Parvis

Filed: May 15, 2001

Docket No.: 62002-1751

For: Method and Apparatus for Low Energy Electron Enhanced Etching or Substrates in an AC or DC Plasma Environment

The following is a list of documents enclosed:

Return Postcard
Fifth Response
Amendment Transmittal

Further, the Commissioner is authorized to charge Deposit Account No. 20-0778 for any additional fees required. The Commissioner is requested to credit any excess fee paid to Deposit Account No. 20-0778.